

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 10/591,343
Applicants: Masaru SASAKI, et al.
Filing Date: August 31, 2006
For: METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE
AND PLASMA OXIDATION METHOD
Group Art Unit: 2813
Examiner: MALEK, M.

SIR:

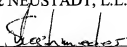
Attached hereto for filing are the following papers:

**AMENDMENT AND REQUEST FOR RECONSIDERATION
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Credit card payment is being made online (if electronically filed), or is attached hereto (if paper filed), in the amount of \$140.00 to cover any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time.

Respectfully submitted,

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